

In re Application of:

Christian Kratzsch et al.

Serial No.:

09/807,061 07/09/2001

Filing Date: For:

Method For Shaping Materials With Plasma-Inducing

High-Energy Radiation

Group Art Unit:

2853

Examiner:

Blaise L. Mouttet

Attorney's Docket No.:

STUR-35

MAIL STOP ISSUE FEE Commissioner For Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

## **COMMUNICATION ACCOMPANYING PAYMENT OF ISSUE FEE**

Enclosed with this communication is a check in the amount of \$685.00 in payment of the Issue Fee (small entity) for the above-identified application.

Please note that the Notice of Allowance incorrectly identified the Applicant as a large entity. However, the above application was filed on the basis of small entity status.

Applicant is submitting herewith copies of the following:

- (1) Filing Of Patent Application Under 37 CFR 1.10, asserting small entity status of the application; and
  - (2) Filing Receipt, indicating that the application was filed as a small entity.

Respectfully submitted,

Scott R. Foster Reg. No. 20,570

Pandiscio & Pandiscio 470 Totten Pond Road Waltham, MA 02451-1914

Tel. (781) 290-0060

## UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Christian Kratzsch et al.

For:

Method For Shaping Materials With Plasma-Inducing

**High-Energy Radiation** 

Attorney's Docket No.:

STUR-35

Date:

April 6, 2001

BOX PCT Assistant Commissioner For Patents Washington, D.C. 20231

Sir:

## FILING OF PATENT APPLICATION UNDER 37 CFR 1.10

The attached patent application is being filed under the provisions of 37 CFR 1.10.

Applicants hereby claim foreign priority benefits under Title 35, United States Code, Section 119, of International Application No. PCT/DE99/00697, filed March 13, 1999 and German Patent Application No. 198 46 191.7, filed October 7, 1998.

Applicants' attorney is also submitting the requisite fee on the basis of Small Entity Status, which the Applicants hereby assert, as calculated on the attached transmittal letter.

"EXPRESS MAIL" MAILING LADEL NUMBER EF320348447US

DAYE OF DEPOSIT

HEBERY CENTERY THAT THIS PAPER OFFEE IS BEING DEPOSITED WITH THE HEBERD STATES POSTAL SERVICE TEXPHESS MAIL POST OFFICE TO ADDRESSEE SERVICE UNDER 37 CFR 1.10 ON THE DATE INDICATED ABOVE AND ID ADDRESSED TO THE ASSISTANT COMMISSIONER FOR PATENTS, WASHINGTON, D.C. 2021.

Scott R. Foster

(SIGNATURE)

PERSON MAILING

Respectfully submitted

Scott R. Foster Reg. No. 20,570

Pandiscio & Pandiscio 470 Totten Pond Road

Waltham, MA 02451-1914

(781) 290-0060

bawforms xpresfor.ltr